

II. CLAIM AMENDMENTS

1. (Currently Amended) Device for manipulating substrates (11) inside and outside an ultraclean workroom (15) with a storage room and a sluice device (17), the sluice device being provided between the storage room (20) and the ultraclean workroom (15), and providing means by which a substrate cassette (12) accommodated under ultraclean room conditions in a box can be [[removed from]] accessed in the box under ultraclean room conditions [[or reintroduced into the box]], and with a first manipulating device (51) by means of which substrates (11) can be placed in the cassette (12) and can be removed from [[this]] the cassette, is hereby characterized in that the storage room (20) is adapted for holding a multiple number of the boxes [[(13)]] accommodated in row and/or column arrangement, and is [[on]] overhanging, substantially the entire ultraclean workroom.

2. (Currently Amended) Device [[according to claim 1]] for manipulating substrates (11) inside and outside an ultraclean workroom (15) with a storage room and a sluice device (17), the sluice device being provided between the storage room (20) and the ultraclean workroom (15), and providing means by which a